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SSI-04001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

William Dale Jones

Serial No.: 10/680,783

Filed: October 6, 2003

For: **HIGH-PRESSURE PROCESSING
CHAMBER FOR A
SEMICONDUCTOR WAFER**

) Group Art Unit: 1763

) Examiner: Lund, Jeffrie Robert

) **TRANSMITTAL LETTER**

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Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed please find a Response to the final office action mailed January 30, 2006 for filing with the U.S. Patent and Trademark Office.

The Commissioner is authorized to charge any additional fee or credit any overpayment to our Deposit Account No. 08-1275. An originally executed duplicate of this transmittal is enclosed for this purpose.

Respectfully submitted,
HAVERSTOCK & OWENS LLP

Dated: 3-27-06

By: Thomas B. Haverstock

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CERTIFICATE OF MAILING (37 CFR § 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

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HAVERSTOCK & OWENS LLP.
Date: 3/28/06 By: JW